

<b>Notice of References Cited</b>	Application/Control No. 10/672,337	Applicant(s)/Patent Under Reexamination CASPI ET AL.	
	Examiner Wayne Cai	Art Unit 2617	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0048364	12-2001	Kalthoff et al.	340/573.1
*	B	US-2001/0046215	11-2001	Kim, Ki-Chul	370/329
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
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**FOREIGN PATENT DOCUMENTS**

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	N					
	O					
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